

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shinji MAEKAWA et al.)
Application No. 10/573,155) Art Unit: 2895
Filed: March 23, 2006) Confirmation No. 6581
For: SEMICONDUCTOR DEVICE AND METHOD)
FOR MANUFACTURING THE SAME)

INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office
Customer Window, Mail Stop RCE
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. In accordance with the policies of the U.S. Patent and Trademark Office, only copies of newly cited foreign patents and non-patent literature are being submitted.

Applicants wish to note that the reference cited is a Full English Translation of JP 2003-123047 which was the basis for Section 102 and 103(a) rejections in the Office Action mailed March 6, 2009.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fee required in connection with this filing, and any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: Jeffrey L. Costellia, Reg. # 35483/
Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
401 9th Street, N.W.
Suite 900
Washington, D.C. 20004-2128
(202) 585-8000